Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L6	554	((robot or arm or grip$3) and (vacuum or suction) and (wafer or disk or disc or substrate or semiconductor)).clm.	US-PGPUB	OR	ON	2005/08/29 09:55
L7	273	((robot or arm or grip$3) and (vacuum or suction) and (wafer or disk or disc or substrate or semiconductor) and (cavity or chamber)).clm.	US-PGPUB	OR	ON	2005/08/29 09:57
L8	56	((robot or arm or grip$3) and (vacuum or suction) and (wafer or disk or disc or substrate or semiconductor) and (cavity or chamber) and (port or orifice or duct)).clm.	US-PGPUB	OR	ON	2005/08/29 10:01
L9	56	((robot or arm or grip$3) and (wafer or disk or disc or substrate or semiconductor) and (cavity or chamber) and ((port or orifice or duct or hole) with (vacuum or suction))).clm.	US-PGPUB	OR	ON	2005/08/29 10:03
L10	12	((robot or arm or grip$3) and (wafer or disk or disc or substrate or semiconductor) and (cavity or chamber) and ((port or orifice or duct or hole) adj2 (vacuum or suction))).clm.	US-PGPUB	OR	ON	2005/08/29 10:04